



INTERNATIONAL
GEMOLOGICAL
INSTITUTE

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LABORATORY GROWN DIAMOND REPORT

December 19, 2024

IGI Report Number **LG669409416**

Description **LABORATORY GROWN DIAMOND**

Shape and Cutting Style **EMERALD CUT**

Measurements **8.63 X 6.19 X 4.24 MM**

GRADING RESULTS

Carat Weight **2.20 CARATS**

Color Grade **G**

Clarity Grade **VS 1**

ADDITIONAL GRADING INFORMATION

Polish **EXCELLENT**

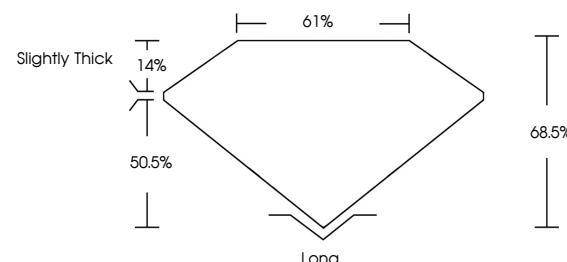
Symmetry **EXCELLENT**

Fluorescence **NONE**

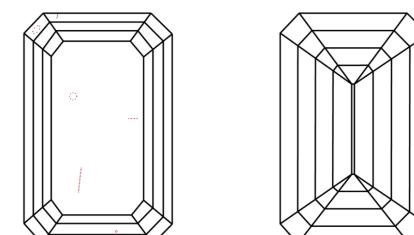
Inscription(s) **IGI LG669409416**

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

PROPORTIONS



CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.

www.igi.org

LG669409416
Report verification at igi.org

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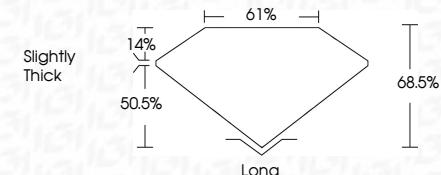
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Sample Image Used



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December 19, 2024	IGI Report No LG669409416
	EMERALD CUT
	8.63 X 6.19 X 4.24 MM
Carat Weight	2.20 CARATS
Color Grade	G
Clarity Grade	VS 1
Depth	68.5%
Table	61%
Grade	Slightly Thick
Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	IGI LG669409416

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Type IIa